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APPLICATION NO.	F	ILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/015,880	10/015,880 12/13/2001		Viktors Berstis	AUS920011011US1	AUS920011011US1 2607	
45993	7590	11/04/2004		EXAMINER		
IBM CORE	ORATIO	ON (RHF)	PERUNGAVOOR, SATHYANARAYA V			
C/O ROBER	RT H. FRA	NTZ				
P.O. BOX 2	23324		ART UNIT	PAPER NUMBER		
OKLAHOM	A CITY.	OK 73123	2625			

DATE MAILED: 11/04/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

		Applicatio	II NO.	Applicant(s)				
-		10/015,88	0	BERSTIS, VIKTORS				
	Office Action Summary	Examiner		Art Unit				
		Sath Perur	ngavoor	2625				
T	he MAILING DATE of this communication	on appears on the	cover sheet with	the correspondence address				
	• •		O EVDIDE 2 MON	ITU(C) EDOM				
THE MAI - Extension after SIX (- If the peric - If NO peri - Failure to Any reply	TENED STATUTORY PERIOD FOR I LING DATE OF THIS COMMUNICAT s of time may be available under the provisions of 37 of 6) MONTHS from the mailing date of this communical and for reply specified above is less than thirty (30) day od for reply is specified above, the maximum statutory reply within the set or extended period for reply will, by received by the Office later than three months after the tent term adjustment. See 37 CFR 1.704(b).	FION. CFR 1.136(a). In no eve tion. s, a reply within the statu, y period will apply and will y statute, cause the appl	ent, however, may a reply atory minimum of thirty (3 Il expire SIX (6) MONTHS ication to become ABANI	by be timely filed 0) days will be considered timely. S from the mailing date of this communication. DONED (35 U.S.C. § 133).				
Status								
1)⊠ Re	sponsive to communication(s) filed or	12/13/2001						
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clo	sed in accordance with the practice u	nder <i>Ex parte Qu</i>	ayle, 1935 C.D. 1	1, 453 O.G. 213.				
Disposition	of Claims							
•	aim(s) 1-21 is/are pending in the appli	cation						
,	4a) Of the above claim(s) is/are withdrawn from consideration.							
	aim(s) is/are allowed.							
	aim(s) <u>1-21</u> is/are rejected.							
	aim(s) is/are objected to							
	aim(s) are subject to restriction	and/or election re	equirement.					
Application	Paners							
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/ 	e specification is objected to by the Ex e drawing(s) filed on <u>12/13/2001</u> is/are		or h\M ahiaatad	to by the Evaminer				
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11)[] 1116	e dath of declaration is objected to by	the Examiner. No	te the attached C	Mile Action of form 1 10-132.				
Priority und	er 35 U.S.C. § 119							
a) / 1.[2.[3.[Certified copies of the priority doc	uments have bee uments have bee ne priority docume Bureau (PCT Rule	n received. n received in App ents have been re e 17.2(a)).	lication No ceived in this National Stage				
Attachment(s)								
2) Notice of 3) Informati	References Cited (PTO-892) Draftsperson's Patent Drawing Review (PTO-90) On Disclosure Statement(s) (PTO-1449 or PTO 0)(s)/Mail Date 12/13/2001.		Paper No(s)/N	nmary (PTO-413) Mail Date rmal Patent Application (PTO-152)				
S. Patent and Trader	mark Office			D 1 (D 111)				

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DETAILED ACTION

Drawings

Figures 3a and 3b should be designated by a legend such as --Prior Art--because only that which is old is illustrated. See MPEP § 608.02(g). Corrected drawings in compliance with 37 CFR 1.121(d) are required in reply to the Office action to avoid abandonment of the application. The replacement sheet(s) should be labeled "Replacement Sheet" in the page header (as per 37 CFR 1.121(d)) so as not to obstruct any portion of the drawing figures. If the changes are not accepted by the examiner, the applicant will be notified and informed of any required corrective action in the next Office action. The objection to the drawings will not be held in abeyance.

Double Patenting

A rejection based on double patenting of the "same invention" type finds its support in the language of 35 U.S.C. 101 which states that "whoever invents or discovers any new and useful process ... may obtain a patent therefor ..." (Emphasis added). Thus, the term "same invention," in this context, means an invention drawn to identical subject matter. See *Miller v. Eagle Mfg. Co.*, 151 U.S. 186 (1894); *In re Ockert*, 245 F.2d 467, 114 USPQ 330 (CCPA 1957); and *In re Vogel*, 422 F.2d 438, 164 USPQ 619 (CCPA 1970).

A statutory type (35 U.S.C. 101) double patenting rejection can be overcome by canceling or amending the conflicting claims so they are no longer coextensive in scope. The filing of a terminal disclaimer <u>cannot</u> overcome a double patenting rejection based upon 35 U.S.C. 101.

Claims 1-4, 9, 10, 14-17, 21 are provisionally rejected under the judicially created doctrine of obviousness-type double patenting as being unpatentable over claims 1-

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4,8,9,13,14,17 of copending Application No. 10015492. Although the conflicting claims are not identical, they are not patentably distinct from each other because the invention disclosed in the instant application and claimed in the copending application are obvious variants over each other. The only difference of sequential exposure of an image would be at least obvious if not inherent.

Furthermore, claims in the instant application are broader than the claims in the copending application.

For example, claim 1 of instant application encompass the subject matter that overlaps with the subject matter covered by claim 1 of the copending application as follows:

Copending application discloses the two-dimensional senor array (Lines 7-8, Claim 1) and instant application discloses a row of sensors. Two dimensional sensor array encompasses both rows and columns.

Copending application discloses the non-uniform distribution of sensors (Lines 3-6, Claim 1), while the instant application discloses varying distances between sensors. It is obvious that non-uniform and varying are synonyms.

Copending application discloses the sampling of sensors (Lines 10-12, Claim 1) and the instant application discloses sampling the sensors by sequentially exposing the image. Sampling an image with one row of sensors would entail sequential exposure to an image.

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Similarly, Claims 2-4,9,14-17,21 of instant application encompass the subject matter that overlaps with the subject matter covered by claims 2-4,7,9,12-14,17 respectively of the copending application.

This is a <u>provisional</u> obviousness-type double patenting rejection because the conflicting claims have not in fact been patented.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States

Claims 1, 2, 4-6, 8-10, 14-16, 18, 19, 21 are rejected under 35 U.S.C. 102(b) as being anticipated by Resnikoff et al (U.S. Patent Number 4,574,311).

20 Regarding claim 1, Resnikoff et al. discloses a method of producing a sampled image comprising the steps of (fig. 6):

providing a plurality of sensor positions in a row arrangement non-uniformly distributed with varying distances between each adjacent pair of sensor positions according to a first predetermined schema and (Fig. 9b, Col. 4 Lines 22-26 and 35-36, Col. 5 Lines 45-49; Cited reference discloses the Poisson disc process, which is a non-

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uniform distribution schema. This schema is applied to provide sensor positions in a row arrangement.);

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sampling an image by sequentially exposing image portions to said row arrangement to obtain a first set of data samples representing non-uniformly spaced points in said image (Col. 7 Lines 25-31 and 37-39).

Regarding claim 2, Resnikoff et al. discloses the method as set forth in Claim 1 wherein said first predetermined schema comprises a pseudo-random schema (Fig. 9b, Col. 4 Lines 22-26).

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Regarding claim 4, Resnikoff et al. discloses the method as set forth in Claim 1 further comprising the step of assigning a reference identifier to said first predetermined schema (Fig. 12, Col. 9 Lines 30-55).

Regarding claim 5, Resnikoff et al. discloses the method as set forth in Claim 1 wherein said step of sampling an image by sequentially exposing image portions to said row arrangement comprises selectively sampling according to a second predetermined schema such that each sensor position is sampled in a non-uniformly varying spatial manner (Col. 3 Lines 23-27, Col. 7 Lines 25-31 and 37-39).

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Regarding claim 6, Resnikoff et al. discloses the method as set forth in Claim 5 wherein said second predetermined schema comprises a pseudo-random schema (Col. 8 Lines 10-15; Poisson disc sampling disclosed is a pseudo-random schema).

Regarding claim 8, Resnikoff et al. discloses the method as set forth in Claim 5 further comprising the step of assigning a reference identifier to said first predetermined schema (Fig. 12, Col. 9 Lines 30-55).

Regarding claim 9, Resnikoff et al. discloses the method as set forth in Claim 1 further comprising the step of interpolating a set of data samples representing uniformly spaced data samples from said first set of data samples (Col. 9 Lines 27-29 and 36-40).

Regarding claim 10, Resnikoff et al. discloses a computer readable medium encoded with software for producing a sampled image using an sensor array having sensor positions in a row arrangement distributed with varying distances between each adjacent pair of sensor positions according to a first predetermined schema, said software causing a processor to perform the steps of (Col. 9 Lines 25-29 and 62-68):

sequentially exposing image portions to said row arrangement and sampling said (Col. 7 Lines 37-39);

sensor positions to obtain a first set of data samples representing non-uniformly spaces points in said image (Col. 7 Lines 25-34, Col. 9 Lines 25-29).

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Regarding claim 14, Resnikoff et al. discloses the computer readable medium as set forth in Claim 10 further comprising software for interpolating a set of data samples representing uniformly spaced data samples from said first set of data samples (Col. 9 Lines 25-29 and 62-68).

Regarding claim 15, Resnikoff et al. discloses a system for producing a sampled image comprising (fig. 6):

a plurality of sensors positioned in a row arrangement distributed with varying distances between each adjacent pair of sensor according to a first predetermined schema and (Col. 5 Lines 45-49, Col. 4 Lines 22-26 and 35-36);

means for sampling an image by sequentially exposing image portions to said row arrangement to obtain a first set of data samples representing non-uniformly spaces points in said image (Col. 7 Lines 25-31 and 37-39).

Regarding claim 16, Resnikoff et al. discloses the system as set forth in Claim 15 wherein said first schema for sensor positioning is a pseudo-random schema (Fig. 9b, Col. 4 Lines 22-26).

Regarding claim 18, Resnikoff et al. discloses the system as set forth in Claim 15 wherein said means for sampling an image composes a means for selectively sampling according to a second predetermined schema such that each sensor position is sampled in a varying spatial manner (Col. 3 Lines 23-27, Col. 7 Lines 25-31 and 37-39).

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Regarding claim 19, Resnikoff et al. discloses the system as set forth in Claim 18 wherein said second predetermined schema comprises a pseudo-random schema (Col. 8 Lines 10-15; Poisson disc sampling disclosed is a pseudo-random schema).

Regarding claim 21, Resnikoff et al. discloses the system as set forth in Claim 15 further comprising a means for generating a uniformly-spaced data sample by interpolating said first set of data samples (Col. 9 Lines 27-29 and 36-40).

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 3, 7, 13, 17 and 20 are rejected under 35 U.S.C. 103(a) as being unpatentable over Resnikoff et al in view of Tansley (U.S. Patent Number 5,818,977).

Regarding claim 3, Resnikoff et al. discloses that any schema can be used in the arrangement of sensors (Col. 5 Lines 62-64). However, Resnikoff et al. does not expressly disclose the use of a nonlinear polynomial schema.

In the same field of endeavor, Tansley discloses a nonlinear polynomial schema to define the sensor characteristics (Col. 2 Lines 50-52 and 62-66).

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Resnikoff et al. clearly states that any schema can be used in the arrangement of sensors. Mere interpretation of old and well-know schema as nonlinear polynomial schema into Resnikoff et al, would have been obvious modification for one of ordinary skill in the art. It would have also been obvious to one with ordinary skill in the art at the time of invention to combine the teachings of Resnikoff et al. and Tansley such that a nonlinear polynomial schema is realized, because the modification would avoid moiré effect that becomes apparent at harmonics and a nonlinear polynomial schema would be used provided that requirement of broad spectral or harmonic content is met.

Regarding claim 13, Resnikoff et al. the computer readable medium as set forth in the discussion claim 11. Resnikoff et al. discloses that any schema can be used in sampling of sensors (Col. 5 Lines 62-64). Though Resnikoff et al. does not expressly disclose the use of a nonlinear polynomial schema.

Tansley discloses a nonlinear polynomial schema to define the sensor characteristics (Col. 2 Lines 50-52 and 62-66).

Resnikoff et al. clearly states that any schema can be used in sampling. Mere interpretation of old and well-know schema as nonlinear polynomial schema into Resnikoff et al, would have been obvious modification for one of ordinary skill in the art. It would have also been obvious to one with ordinary skill in the art at the time of invention to combine the teachings of Resnikoff et al. and Tansley such that a nonlinear polynomial schema is realized, because the modification would avoid moiré effect that becomes apparent at harmonics and a nonlinear polynomial schema would be used

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provided that requirement of broad spectral or harmonic content is met. It would have also been obvious to one with ordinary skill in the art at the time of invention to modify the teachings of Resnikoff et al. and develop software to perform selective sampling on sensors with a nonlinear polynomial schema. Since most image processing systems include processors that require software to perform functions. It would be obvious if not inherent to use software to perform selective sampling with a nonlinear polynomial schema.

Regarding claims 7 and 20, Resnikoff et al. discloses that any schema can be used in sampling of sensors (Col. 5 Lines 62-64). Though Resnikoff et al. does not expressly disclose the use of a nonlinear polynomial schema.

Tansley discloses a nonlinear polynomial schema to define the sensor characteristics (Col. 2 Lines 50-52 and 62-66).

Resnikoff et al. clearly states that any schema can be used in the sampling of sensors. Mere interpretation of old and well-know schema as nonlinear polynomial schema into Resnikoff et al, would have been obvious modification for one of ordinary skill in the art. It would have also been obvious to one with ordinary skill in the art at the time of invention to combine the teachings of Resnikoff et al. and Tansley such that a nonlinear polynomial schema is realized, because the modification would avoid moiré effect that becomes apparent at harmonics and a nonlinear polynomial schema would be used provided that requirement of broad spectral or harmonic content is met.

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Claims 11 and 12 are rejected under 35 U.S.C. 103(a) as being unpatentable over Resnikoff et al

Regarding claim 11, Resnikoff et al. discloses a computer readable medium encoded with software for sampling sensors as set forth in the discussion for claim 10.

Resnikoff et al. also discloses selectively sampling sensors as set forth in the discussion for claim 5.

Resnikoff et al. does not expressly disclose the software for selectively sampling sensors.

It would have been obvious to one with ordinary skill in the art at the time of invention to modify the teachings of Resnikoff et al. and develop a software to perform selective sampling on sensors. Since most image processing systems include processors that require software to perform functions. It would be obvious if not inherent to use software to perform selective sampling.

Regarding claim 12, Resnikoff et al. further teaches the use of pseudo-random schema (Col. 8 Lines 10-15; Poisson disc sampling disclosed is a pseudo-random schema). It would have been obvious to one with ordinary skill in the art at the time of invention to modify the teachings of Resnikoff et al. and develop software to perform selective sampling on sensors with a pseudo-random schema. Since most image processing systems include processors that require software to perform functions. It

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would be obvious if not inherent to use software to perform selective sampling with a pseudo-random schema.

Contact Information

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Sath Perungavoor whose telephone number is (703) 306-4116. The examiner can normally be reached on Monday to Friday from 8:30am to 5:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Bhavesh Mehta whose telephone number is (703) 308-5246, can be reached on Monday to Friday from 9:00am to 5:00pm. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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Sath Perungavoor

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28 October 2004

BHAVESH M. MEHTA SUPERVISORY PATENT EXAMINER

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